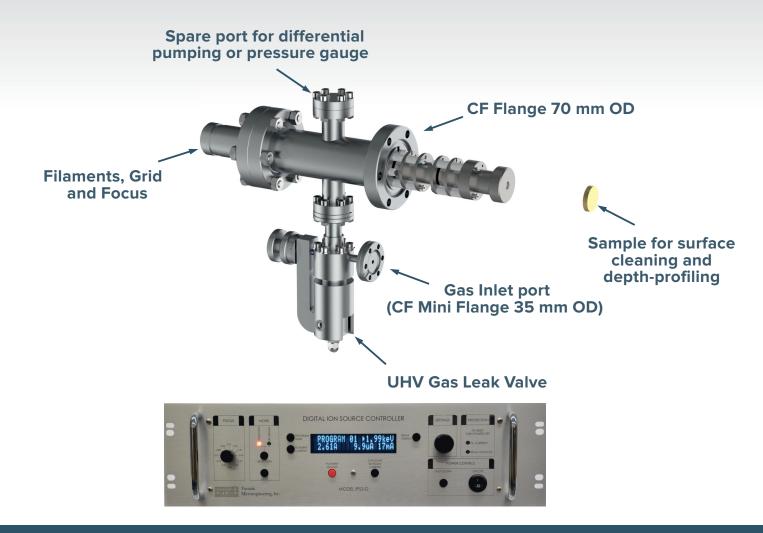
# IONEC - Ion Sputter Gun Model IG70-DP with exchangeable apertures



#### **Applications**

The IG70-DP Ion gun is designed for sample surface cleaning and depth profiling with Auger electron spectroscopy.

Surface treatments with IG70-DP are applicable to a wide range of materials from metals, semiconductors, and oxides, to thin films and 2D layers.

### **Features:**

- Precision sputtering for sample cleaning and depth profiling
- Low operating gas pressure:  $10^{-6} 10^{-7}$  Torr
- Wide range of ion beam diameters and sample distances
- Two long life filaments
- Variety of operating gases: Ar, Noble or Reactive



Canada: 200 Stronach Cres., London, Ontario, N5V3A1 USA: 6405 Inducon Drive West, Sanborn (Niagara County), NY, 14132 TEL. (519) 457-0878, FAX (519) 457-0837 E-mail: info@ocivm.com Website: www.ocivm.com

# **IONEC - MODEL IG70-DP**

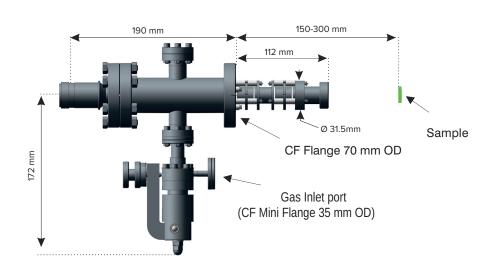
# **Specifications**

### **Precision Power Supply: Model IPS3-D**

Ion Source	Electron impact ionization in magnetic field	Outputs:	Filament current: 3.5 A max Grid voltage: 150 V in reference to filament
Ionization Cathode	Tungsten - rhenium filament directly mounted on 70 mm OD CF flange		Beam voltage: 0 – 3.0 kV Focus voltage: Factor 0.3 - 0.85x of Beam Energy Emission current: 0 - 45 mA
Beam Current	1.0 μA at 0.25 keV 2.0 μA at 0.5 keV 5.0 μA at 1.0 keV 10 μA at 2.0 keV	Monitoring:	Beam Energy Voltage and Currents: Filament Electron Emission, total Ion Beam
	15 μA at 3.0 keV	Manual Control:	of all voltages and Filament current via rotary dials and selection buttons
Operating pressure	5.0 x 10 <sup>-6</sup> torr - typical		
Beam Energy	0 - 3.0 keV	On-board Automation:	9 adjustable operating programs: outgassing, stand-by, filament forming, constant emission current and diagnostics programs
Beam Size	From 5 to 25 mm in diameter	DC Control	
Beam Uniformity	< 5%	PC Control:	Full control of all functions, PC software is required
Gas Innut		Display:	Vacuum fluorescent display
Gas Input	Direct gas input to ion source via leak valve	Protection:	Short circuit, arc and over voltage protection
Mounting	2¾" (70 mm) OD CF flange	laautu	<b>3</b>
Bakeability	Under vacuum - 250°C max.	Input:	100/110 V AC 50/60 Hz or 220/240 V AC 50 Hz
-		Size:	19" Rack mount box with 3U (5.25", 133 mm) in height and 17.5" (440 mm) in depth, 12 in weight

# **Ordering Guide**

IG70-DP	lon sputtering gun with direct gas inlet, adjustable beam size, and CF 2 ¾" (70 mm) OD mounting flange
IPS3-D	Digital power supply with voltage range $0 - 3.0$ kV
LV-UHV	UHV Precision Gas Leak Valve



**Schematic** 

